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# Resistive switching in FTO/CuO-Cu$_2$O/Au memory devices

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Memristors are considered to be next-generation non-volatile memory devices owing to their fast switching and low power consumption. Metal oxide memristors have been extensively investigated and reported to be promising devices, although they still suffer from poor stability and laborious fabrication process. Herein, we report a stable and power-efficient memristor with novel heterogenous electrodes structure and facile fabrication based on CuO-Cu$_2$O complex thin films. The proposed structure of the memristor contains an active complex layer of cupric oxide (CuO) and cuprous oxide (Cu$_2$O) sandwiched between fluorine-doped tin oxide (FTO) and gold (Au) electrodes. The fabricated memristors demonstrate bipolar resistive switching (RS) behavior with a low working voltage (~1 V), efficient power consumption, and high endurance over 100 switching cycles. We suggest the RS mechanism of the proposed device is related to the formation and rupture of conducting filaments inside the memristor. Moreover, we analyze the conduction mechanism and electron transport in the active layer of the device during the RS process. Such a facile fabricated device has a promising potential for future memristive applications.

### 1. Introduction

The memristor (memory + resistor) was first proposed by Leon Chua in 1971 as the fourth fundamental circuit element \[1]. A typical structure of two-terminal memristors consists of a switching layer sandwiched between two metallic electrodes. Depending on the switching layer properties, memristors are classified as bulk, interface, and filament types. The filament type memristors continue to attract more research attention due to their superior performance. Among filament types memristors, metal oxides are the most commonly used materials in which oxygen vacancies form conducting filaments that are responsible for resistive switching behavior \[2]. There have been several studies on metal-oxide memristors such as TiO$_2$ \[3], HfO$_2$ \[4], ZnO \[5], AlO$_x$ \[6], WO$_3$ \[7], TaO$_x$ \[8] etc. Moreover, cupric oxide (CuO) has been also reported to show bipolar memristive behavior \[9–11]. In copper oxide memristors, the active layer is often made by thermal annealing \[12], or solution processing \[13], which features inexpensive and low-power operation \[14]. The facile fabrication of copper oxide memristors is an advantage over other types of metal oxide memristors however, further efforts are required to improve the stability, endurance, and retention time during the RS mechanism \[15, 16]. In this work, we report a stable and power-efficient memristor with novel structure and facile fabrication based on CuO-Cu$_2$O complex thin films. The fabricated memristor consists of CuO-Cu$_2$O complex thin films as a switching layer, which is sandwiched between FTO and deposited gold (Au) electrodes. The FTO as the bottom electrode acts as an oxygen vacancy reservoir where oxygen vacancies can be stored or supplied during the resistive switching \[17]. Moreover, FTO can tolerate high annealing temperature without increasing the sheet resistance during copper oxidization \[18]. Au electrodes are deposited on top of the device because compared to platinum (Pt) the Au contact is less expensive and demonstrates higher endurance \[19]. Structural and memristive properties are characterized using Raman spectroscopy, UV-Vis absorbance, and current-voltage (I-V) measurements. The memristivity is identified by the pinch hysteresis loop and switching cycles from the high resistance state (HRS) to the low resistance state (LRS). The memristor possesses a low operation voltage, high endurance, and uniformity. Moreover, the carrier transport mechanisms have been investigated, suggesting the space charge limited conduction (SCLC) to be the main conduction mechanism.

### 2. Fabrication and experimental methods

A 100 nm-thick copper (Cu) thin film was deposited on the FTO substrate using electron beam evaporation at room temperature. The vacuum pressure was kept at 6×10$^{-6}$ Torr during the deposition process. The as-deposited Cu metal film was annealed at 400 °C for 45 minutes in an oxygen ambient environment to form the copper oxide thin film. We used Horiba LabRam micro Raman spectrometer and Cary 500 UV-Vis-NIR Spectrophotometer to characterize the Raman and absorbance properties of the thin film, respectively. The Raman measurements are performed using a continuous red (632 nm) laser as the excitation source. The elastically scattered light is filtered out to detect the weaker inelastically scattered light from optical phonons. The Raman spectrum is recorded in the range of 200 - 700 cm$^{-1}$ to confirm the presence of copper oxide elements by comparing the position of phonon modes with existing literature. We also measured the absorbance of the grown thin films in the wavelength range of 300 – 800 nm, where the excitonic peak and bandgap of the copper oxide can be observed. To achieve FTO/CuO-Cu$_2$O/Au devices, the 50 nm-thick circle gold (Au) electrodes with different areas were deposited using a shadow mask and electron beam evaporation. We used the Keithley 4200 SCS parameter analyzer and a probe station for the current-voltage I-V characterization of fabricated devices. For each device on the sample, we applied the consecutive external DC voltages with different polarities between the Au and FTO as top and bottom electrodes. All the measurements were performed at room temperature.

![Fig. 1 The Raman scattering spectra of CuO-Cu$_2$O thin films excited by the red laser.](image-url)
3. Results and discussions: Fig. 1 plots the Raman scattering spectra of the grown copper oxide thin film. The three peaks at 307 cm\(^{-1}\), 355 cm\(^{-1}\), and 640 cm\(^{-1}\) are the Raman fingerprints of CuO, which is consistent with relevant studies [20, 21]. These strong peaks are assigned to \(A_g\), \(B_{1g}\), and \(2B_{2g}\) phonon modes, which can shift slightly depending on the annealing temperature of CuO [22]. There are also broad humps between 390 cm\(^{-1}\) and 640 cm\(^{-1}\), which indicate the presence of cuprous oxide (Cu\(_2\)O) phase [23]. Therefore, the prepared copper oxide thin film contains both CuO and Cu\(_2\)O phases. Fig. 2 shows the optical absorption of CuO-Cu\(_2\)O complex thin films annealed at 400\(^\circ\)C. The thin films exhibit high absorbance in the UV region centered around 350 nm. The inset of Fig. 2 demonstrates the Tauc plot, in which the corresponding bandgap is analyzed by extrapolating the linear part of the curve. The obtained indirect bandgap is 1.45 eV that is within the range reported by [24, 25].

![Absorbance spectra of CuO-Cu\(_2\)O thin films. The inset demonstrates the Tauc plot representing the extrapolation of the linear part of the curve to achieve the indirect bandgap of CuO-Cu\(_2\)O thin films.](image)

A schematic picture and the structure of two-terminal memory devices studied in this work are shown in Fig. 3a. Before performing I-V measurements, the electroforming process is required to create a sufficiently strong electric field and initiate a soft breakdown of the switching layer in the device. As a result, massive oxygen vacancies are introduced into the copper oxide layer, which can form nanoscale conductive filaments [26]. To this aim, the applied voltage is slowly increased with a current compliance of 1 mA to protect the device from a permanent breakdown (not shown here). The electroforming process is observed at around -6 V, where the current suddenly increases and stabilizes afterward. Then, when we sweep back the voltage from negative to a positive value with a sweep rate of 10 mV/s, an abrupt current change occurs at approximately 3.2 V, indicating resistive switching (RS) from an initial low resistance state (LRS) to a high resistance state (HRS), which is called the “RESET” process. Subsequently, we sweep the voltage from positive to a negative value, and the device remains at HRS until another RS occurs around -1 V, and the device switches back from HRS to LRS, which is called the “SET” process. The memristive behavior of the device with the smallest electrode’s diameter of 0.2 mm can be observed from the measured current-voltage (I-V) characteristics shown in Fig. 3b. We prepared multiple devices with different Au electrode areas, and the device with the smallest diameter of 0.2 mm exhibits the best performance. Devices with the larger Au electrode areas demonstrate poor performance in terms of endurance, retention time, and on/off ratio. A possible reason can be related to the local resistive switching in the device due to the formation of highly localized filaments [33]. As we expected, the I-V characteristics are asymmetric, which can be used to differentiate similar conduction mechanisms from each other [29]. By sweeping voltage repeatedly between positive and negative values, the I-V curves show little difference between first and last sweeping cycles, indicating high endurance and reproducibility up to 100 cycling times (Fig. 3c). Thus, the RS behavior is reversible and instantaneous,

![FTO/CuO-Cu\(_2\)O/Au I-V characteristics.](image)

- a The schematic picture (left) and the structure of the fabricated devices (right).
- b A typical RS behavior of the FTO/CuO-Cu\(_2\)O/Au device, where arrows indicating the RS operation cycle with ON and OFF switching.
- c The I-V characteristics at consecutive switching cycles.

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which is important for a reliable nonvolatile memory mechanism. However, the origin of RS mechanism is still in debate, relevant studies on copper-oxide based devices agree on the formation and rupture of conducting filaments with oxygen vacancies accumulation and depletion induced by applying the external voltage [27]. The scattered switching voltage distribution observed at OFF states in Fig. 3c is due to the rupture of filaments, either by ion migration or Joule heating [28]. Moreover, symmetric multilevel transitions occur at both HRS and LRS states around ±1 V where the possible reason might be the hopping conduction in which the shallow trapped electrons can surpass the energy barrier and form the leakage current in discontinuous residual metallic filament [30]. This phenomenon can also suggest a multilevel data storage capability of the device [31]. Another advantage of this device is low power consumption (<4 µW), which is calculated by multiplying the reading voltage (0.2 V) and LRS current values (<20 µA) [32]. Fig. 4a depicts the device endurance performance, in which the current values of LRS and HRS are monitored at 0.2 V. The HRS current state is consistent over 100 cycles, and LRS current also becomes stable after the first several cycles, indicating a good endurance of the device performance.

From the current ratio, the memory window is maintained well at more than one order of magnitude difference thus, we can well distinguish between the binary storage information. The retention characteristic is shown in Fig. 4b, which demonstrate continuous sampling for around $2 \times 10^4$ s at room temperature. The HRS current state remains consistent while the LRS current decays a little bit after $10^3$ s and again maintains consistency around 10 µA. The overall device performance is compared with recent publications in Table 1. To further understand the switching and conduction mechanism of the device, the linear fitting I-V characteristics of positive and negative bias regions are plotted on a separate double logarithmic scale (Fig. 5). In the low voltage negative bias region (Fig. 5a), the curve’s slope is approximately 1 for both HRS and LRS states, indicating the Ohmic conduction is dominant at low voltages ($I \propto V$). It means that thermally generated free carriers in the oxide film mainly contribute to the conduction and exceed injected carriers when the applied bias voltage is low. As the negative voltage scans forward, the curve’s slope increases to 2, which is following Child’s square law ($I \propto V^2$). In the higher field regions, a steep current increase occurs around 1 V due to the formation of filaments and trapping the injected carriers in the oxide layer where $I \propto V^a$ ($a>2$).

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**Fig. 4** Endurance and retention stability performance of the device.  
(a) Endurance performance of the device over 100 consecutive switching cycles.  
(b) Retention performance of the device for around $2 \times 10^4$ s

**Fig. 5** The linear fitting I-V characteristics for the double logarithmic plots of Fig. 3b, indicating the corresponding curve’s slopes and the conduction mechanism of the device.  
(a) Negative voltage bias region  
(b) Positive voltage bias region
Table 1: The device performance comparison between this work and other publications regarding copper oxide resistive switching.

<table>
<thead>
<tr>
<th>Device Structure</th>
<th>Endurance (cycle)</th>
<th>Retention (s)</th>
<th>Set/Reset</th>
<th>Power Consumption (W)</th>
<th>On/Off Ratio</th>
<th>Vforming (V)</th>
<th>Fabrication Technique</th>
<th>Refs.</th>
</tr>
</thead>
<tbody>
<tr>
<td>FTO/CuO-CuO/Au</td>
<td>&gt;100</td>
<td>&gt;2x10^4</td>
<td>-1/+3.2</td>
<td>&lt;4x10^-8</td>
<td>&gt;10</td>
<td>6</td>
<td>thermal annealing</td>
<td>This work</td>
</tr>
<tr>
<td>ITO/CuO/Au</td>
<td>200</td>
<td>&gt;10^4</td>
<td>-0.7/+0.7</td>
<td>&lt;1x10^-6</td>
<td>&gt;10</td>
<td>free</td>
<td>solution processing</td>
<td>[13]</td>
</tr>
<tr>
<td>Al/CuO/SS</td>
<td>-</td>
<td>-</td>
<td>+1.8/-1.8</td>
<td>-</td>
<td>-</td>
<td>-</td>
<td>free</td>
<td>[9]</td>
</tr>
<tr>
<td>Ti/CuO/Pt</td>
<td>100</td>
<td>&gt;10^2</td>
<td>+0.8/-1</td>
<td>6x10^-4</td>
<td>100</td>
<td>14.8</td>
<td>thermal annealing</td>
<td>[33]</td>
</tr>
<tr>
<td>Cu/CuO/Ag/Ag</td>
<td>-</td>
<td>-</td>
<td>-0.8/+0.8</td>
<td>4x10^-3</td>
<td>10</td>
<td>free</td>
<td>solution processing</td>
<td>[14]</td>
</tr>
<tr>
<td>Cu/CuO/Ag/Ag</td>
<td>-</td>
<td>-</td>
<td>+2/-2</td>
<td>-</td>
<td>-</td>
<td>-</td>
<td>thermal annealing</td>
<td>[12]</td>
</tr>
<tr>
<td>TiW/CuO/Cu</td>
<td>-</td>
<td>-</td>
<td>+0.55/-0.3</td>
<td>20x10^-6</td>
<td>&gt;10</td>
<td>free</td>
<td>DC sputtering</td>
<td>[34]</td>
</tr>
</tbody>
</table>

For copper oxide thin films, the traps are well known to be as oxygen vacancies. When traps or oxygen vacancies are gradually filled by injected carriers, the slope reduces to around 2 again [28]. Therefore, the fitting results suggest that the conduction mechanism follows the space charge limited conduction (SCLC) model. This model is constituted of three regions: (1) Ohmic region, (2) Child’s square law or trap-unfilled SCLC region, and (3) trap-filled SCLC region. According to the SCLC theory at higher fields or trap-free SCLC region,

\[ J = \frac{9}{8} \varepsilon \mu \theta \frac{V^2}{d^3} \]

Where \( J \) is the current density, \( \varepsilon \) is the permittivity of the oxide layer, \( \mu \) is the mobility of charge carriers, \( \theta \) is the ratio between free and shallow trapped charge carriers, and \( d \) is the film thickness [35]. In the positive bias region (Fig. 5b), a similar conduction mechanism is observed, which obeys the SCLC model. The LRS state with a slope of 1 is still maintained, which is followed by the Child’s law with a slope of 2 until the rupture of conductive filament gradually occurs, and the device resets back to HRS.

Based on the above analysis, the RS mechanism is bipolar in which the SET and RESET processes occur in different polarities. The forming or SET process is due to a dielectric soft breakdown in the oxide layer [36], and then oxygen ions (\( O^2- \)) move through the filament (oxygen vacancies) to the anode as an oxygen vacancy absorber (FTO). At the anode interface, the oxygen ions oxidize (\( O^2- = O + 2e^- \)), creating an oxygen reservoir [27]. The RESET process occurs at the reverse polarity where oxygen ions are repelled from the anode interface because they are negatively charged. Therefore, based on the external voltage polarity, the oxygen ions are repelled or extracted back to the anode, switching the device between LRS and HRS states. A detailed explanation of the filamentary switching mechanism remains an area of active research.

4. Conclusion: In summary, we reported a facile fabrication method and analyzed the resistive switching behavior of the heterogenous electrodes structure of FTO/CuO-CuO/Au memristor. The copper oxide complex layer after annealing is investigated by Raman and absorbance measurements. The conduction mechanism of this device is also investigated, which follows the space charge limited conduction (SCLC) theory. The achieved results suggest high endurance, low SET voltage, and efficient power consumption of the device. However, further investigations are required to increase the retention time and on/off ratio in this type of memristor.

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